



TFW

# AMENDMENT TRANSMITTAL LETTER

Docket No.  
SON-2563

Application No.  
10/501,155-Conf. #5207

Filing Date  
July 13, 2004

Examiner  
Not Yet Assigned

Art Unit  
2812

Applicant(s): Koichiro Saga

Invention: SURFACE TREATMENT METHOD, SEMICONDUCTOR DEVICE, METHOD OF  
FABRICATING SEMICONDUCTOR DEVICE, AND TREATMENT APPARATUS

## TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	41	- 41 =		x	
Independent Claims	13	- 13 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00

- ☒ Large Entity ☐ Small Entity
- ☒ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 18-0013  
as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

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Dated: June 22, 2005



Docket No.: SON-2563  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Koichiro Saga

Application No.: 10/501,155

Confirmation No.: 5207

Filed: July 13, 2004

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For: SURFACE TREATMENT METHOD,  
SEMICONDUCTOR DEVICE, METHOD OF  
FABRICATING SEMICONDUCTOR DEVICE,  
AND TREATMENT APPARATUS

Examiner: Not Yet Assigned

**FIRST PRELIMINARY AMENDMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows: